

Abstract

In order to reduce an amount of a cleaning liquid remaining in a cleaning basket and to improve efficiency of drying polycrystalline silicon accommodated in the cleaning basket, a cleaning basket (1) is used for at least one of cleaning and drying of polycrystalline silicon in a state in which the polycrystalline silicon is accommodated and includes: a bottom plate (2) provided with a plurality of through holes formed therein; oblique plates (3) each of which has an inner surface (33) that makes, with an upper surface (23) of the bottom plate (2), an angle ($\theta 1$) of not less than 10° and not more than 80° , the oblique plates (3) each being connected to the bottom plate (2) and inclining in an upward and outward direction: and respective side plates (4) which are connected to the oblique plates (3) and which extend in an upward direction.

Figure 3.